



**PATENT APPLICATION**

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Date May 19, 2006

In re the Application of

Fumio KOYAMA et al.

Group Art Unit: 2812

Application No.: 10/801,821

Examiner: S. MULPURI

Filed: June 22, 2004

Docket No.: 111587.01

For: SURFACE EMITTING SEMICONDUCTOR LASER AND MANUFACTURING METHOD  
THEREOF

**LARGE ENTITY PETITION FOR 1<sup>st</sup> - 3<sup>rd</sup> EXTENSION  
OF TIME UNDER 37 C.F.R. §1.136(a) AND  
TRANSMITTAL OF FEE UNDER 37 C.F.R. §1.17**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

Transmitted herewith is a response to the outstanding Official Action in the above-identified patent application. The shortened statutory period having expired April 20, 2006, an extension of time for a period of one month is hereby requested. Attached hereto is our Check No. 179990 in the amount of \$120 in payment for:

x Extension fee for response within first month pursuant to §1.136(a) (\$120.00)  
\_\_\_\_\_ Extension fee for response within second month pursuant to §1.136(a) (\$450.00)  
\_\_\_\_\_ Extension fee for response within third or subsequent month pursuant to §1.136(a) (\$1020.00)

The Commissioner is hereby authorized to charge any additional fee or credit any overpayment associated with this communication to Deposit Account No. 15-0461. Two copies of this petition are enclosed.

Respectfully submitted,

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JAO:TMN/amw

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DEPOSIT ACCOUNT USE  
AUTHORIZATION  
Please grant any extension  
necessary for entry;  
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